



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

2822\$  
#7  
BEP  
2-1303

Attorney Docket No. 249/258

RECEIVED  
TECHNOLOGY CENTER 2800  
FEB 11 2003

In re patent application of

Yeong-kwan KIM, et al.

Group Art Unit: 2822

Serial No. 09/902,607

Examiner: T. Thomas

Filed: July 12, 2001

For: SEMICONDUCTOR DEVICE HAVING THIN FILM FORMED BY ATOMIC LAYER DEPOSITION AND METHOD FOR FABRICATING THE SAME

PETITION FOR EXTENSION OF TIME  
UNDER 37 C.F.R. § 1.136

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

It is respectfully requested that an extension of time for the period indicated below be granted in accordance with the provisions of 37 C.F.R. §1.136 to take the action required in the application identified in caption, as reflected by the papers submitted herewith.

<u>X</u> First Month	\$110 (\$ 55)*
<u>_</u> Second Month	\$300 (\$150)*
<u>_</u> Third Month	\$520 (\$260)*
<u>_</u> Fourth Month	\$520 (\$260)*
<u>_</u> Fifth Month	\$520 (\$260)*
<u>*(Small Entity) TOTAL FEE: \$110.00</u>	

The Commissioner is hereby authorized to charge the necessary extension fees to our Deposit Account No. 5-01645.

Respectfully submitted,

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Registration No. 43,162

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